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				Application Number	10/721,979
				Filing Date	11/25/2003
				First Named Inventor	Shieh, et al.
				Art Unit	2812
				Examiner Name	TBD
Sheet	1	of	1	Attorney Docket Number	TSM02-1241

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
PZ	A	US-6,448,608 B1	09-10-2002	Pham, et al.	
PZ	B	US-6,559,501 B2	05-06-2003	Sung, et al.	
		US-			
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
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Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
PZ	C	OEHRLEIN, G.S., et al., "Surface Science Issues in Plasma Etching," [on-line] IBM Journal of Research and Development, Vol. 43, 1/2 (1999), Retrieved From: http://www.research.ibm.com/journal/rd/431/oehrlein.html	
PZ	D	"Technical Comparison of Floating Gate Reprogrammable Nonvolatile Memories," Technical Paper, Silicon Storage Technology, Inc. (November 2001) pp. 1-8.	

Examiner Signature		Date Considered	11/10/04
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